
OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Application Information**

Application Type::	Regular
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	MAGNETO-RESISTANCE EFFECT ELEMENT BAR EXPOSURE METHOD, MAGNETO-RESISTANCE EFFECT ELEMENT BAR FORMATION METHOD AND MAGNETO-RESISTANCE EFFECT ELEMENT BAR
Attorney Docket Number::	116900
Total Drawing Sheets::	5
Small Entity::	No

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Deceased Inventor
Given Name::	Tsuneo
Family Name::	KAGOTANI
City of Residence::	Chuo-ku
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Hitoshi
Family Name::	HATATE
City of Residence::	Chuo-ku
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Noriaki

Family Name:: KASAHARA
City of Residence:: Chuo-ku
Country of Residence:: Japan

Applicant Authority type:: inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Tetsuya
Family Name:: KUWASHIMA
City of Residence:: Chuo-ku
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-256110	08/30/2002	Yes
Assignee Information			
Assignee Name::		TDK CORPORATION	
Street of mailing address::		1-13-1, Nihonbashi,	
City of mailing address::		Chuo-ku	
State or Province of mailing address::		Toyko	
Country of mailing address::		Japan	
Postal or Zip Code of mailing address::		103-8272	